

# Search Notes



Application/Control No.

09/510,861

Examiner

Kevin Y. Kim

Applicant(s)/Patent under Reexamination

TAMURA, KOICHI

Art Unit

2611

## SEARCHED

Class	Subclass	Date	Examiner
375	327 355 371	4/23/06	lwi
329	302		
	307	4/23/06	lwi
	323		
	325		
	360		
	361		

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
See int. history	Search		
printout		4/23/06	lwi

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR.
Inventor Search	4/23/06	lwi